CORRECTION

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Cite this: *J. Mater. Chem. C*, 2018, **6**, 4327

Correction: An elastomer for epidermal electronics with adjustable adhesion force and stretchability obtained *via* a reverse-micelle-induced process

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DOI: 10.1039/c8tc90069h

rsc.li/materials-c

Correction for 'An elastomer for epidermal electronics with adjustable adhesion force and stretchability obtained *via* a reverse-micelle-induced process' by Junhyung Kim *et al.*, *J. Mater. Chem. C*, 2018, **6**, 2210–2215.

The authors regret that their article was published without an acknowledgements section. The acknowledgements section below should have been displayed.

Acknowledgements

This Research was performed as part of project No. SI1802 (Development of One-patch device for HMI based on 3D Device Printing) and supported by the Korea Research Institute of Chemical Technology (KRICT) and the Global Research Laboratory Program of the National Research Foundation (NRF) funded by the Ministry of Science, Information and Communication Technologies and Future Planning (NRF-2015K1A1A2029679).

The Royal Society of Chemistry apologises for these errors and any consequent inconvenience to authors and readers.

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